

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
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Sun Jin YUN et al. : Confirmation No. 4540
:
U.S. Patent Application No. 10/777,102 : Group Art Unit: 2815
:
Filed: February 13, 2004 : Examiner: DIAZ, JOSE R

For: SUBSTRATE WITH MICROSTRUCTURE FORMED THEREON AND
MANUFACTURING METHOD THEREOF

RESPONSE

MAIL STOP AMENDMENT
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria VA 22313-1450

Sir:

In response to the Office Action of December 24, 2009, reconsideration and allowance of the subject application in view of the following remarks is respectfully requested.